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PATENT
03345-P0017A WWW/GJL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicants | Michael Heuken, <i>et al.</i> |
| Serial No. 09/873,041 | Filing Date: June 1, 2001 |
| Title of Application: | Method And System For Semiconductor Crystal Production With Temperature Management |
| Confirmation No. 5097 | Art Unit: 1765 |
| Examiner | Matthew J. Song |

wMail Stop Non-Fee Amendment
Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

Response to Notice of Non-Compliant Preliminary Amendment (37 C.F.R. §1.121) in Request for Continued Examination Under 37 C.F.R. §1.114

In response to the Notice of Non-Compliant Amendment (37 CFR 1.121) mailed on January 8, 2004 in the above Request for Continued Examination, Applicants herewith present compliant Amendments and Remarks in the above U.S. patent application. Please amend the Claims as set forth below.

Mailing Certificate: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as *First Class Mail* in an envelope addressed to: Commissioner for Patents and Trademarks; Post Office Box 1450; Alexandria, VA 22313-1450.

February 6, 2004

Caroline Gahagan